

		THO	Attorney Docket No. SEL 142	<u>Seria</u>	al No. 5,154	-	
	T OF PUBLICATION TED BY APPLICAN		<u>Applicant</u> Shunpei YAMAZAKI et al			·	
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		U.S	S. PATENT DOCUMENTS				
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE	
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FOREIGN PATENT DOCUMENT							
,	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE	
Loke	WO 90/13148 JP 7-130652 JP 8-078329 JP 10-092576	11/01/90 05/19/95 03/22/96 04/10/98	Cambridge Research and Innovation Ltd. Semiconductor Energy Laboratory Co. Ltd. Semiconductor Energy Laboratory Co. Ltd. Cambridge Display Technology Ltd.			04/18/90 10/29/93 09/05/94 04/18/97 10/24/96	
Loke	JP 10-135468 JP 10-135469 JP 10-247735	05/22/98 05/22/98 09/14/98	Semiconductor Energy Laboratory Co. Ltd. Semiconductor Energy Laboratory Co. Ltd. Semiconductor Energy Laboratory Co., Ltd.			10/24/96	
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				Application Number	09/435,154	/	./
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				Group Art Unit	2811	1	
	(use as many s	heet	s as necessary)	Examiner Name	S. Loke	Con and	<i>"</i>
heet	3	of	3	Attorney Docket Number	SEL 142	CADEMARK S	

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS						
Examiner Initials	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²			
Loke		U.S. Patent Application No. 09/432,662 (pending) to Yamazaki et al, filed November 8, 1999, including specification, claims, drawings and PTO filing receipt.				
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¹ Unique citation designation number. ² Applicant is to place a check mark here if English language Translation is attached.